



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Akram et al.

Serial No.: 09/944,499

Filed: August 30, 2001

For: STEREOLITHOGRAPHIC METHOD  
AND APPARATUS FOR FABRICATING  
STABILIZERS FOR FLIP-CHIP TYPE  
SEMICONDUCTOR DEVICES AND  
RESULTING STRUCTURES

Examiner: Unknown

Group Art Unit: 2813

Attorney Docket No.: 3936.1US (99-0066.1)

CERTIFICATE OF MAILING

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PRELIMINARY AMENDMENT

Box Non-Fee Amendment  
Commissioner for Patents  
Washington, D.C. 20231

Sir:

Prior to examination of the above-referenced patent application on the merits, entry of the amendments as set forth herein is respectfully solicited.